I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, p. o. Box 1450, ALEXANDRIA, VA 22313-1450, on February 23, 2004. The applicant and/or attorney requests the date of deposit as the filing date.

Depositor: Karen Cing-Mars

(Signature & date)

FEB 2 5 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of

February 23, 2004

mars 2/23/04

Ashima Chakravarti, et al.:

Group Art Unit: Not yet assigned

Serial No. 10/707,878 :

Examiner: Not yet assigned

Filed: 1/20/04

International Business Machines Corporation

2070 Route 52

Hopewell Junction, NY 12533

TITLE: Polycrystalline Silicon Layer With Nano-Grain Structure And Method of Manufacture

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the non-US patents and publications as listed on Form PTO-1449, attached hereto.

In citing these documents, no representation is made nor intended as to the pertinency or nonpertinency of the art, that better art than that listed is not available, or that other art is not applicable.

No fee is believed to be due for this submission. If any fees are required, however, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 09-0458.

Respectfully submitted,

Ashima Chakravarti, et al

Ira D. Blecker, Attorney Registration No. 29,894

Telephone No. 845-894-2580

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